

**Amendments to the Claims:**

The following listing of claims will replace all prior versions, and listings, of claims in the application:

1. (Previously Presented) A droplet discharge method for disposing liquid material in a specified quantity on a substrate by discharging the liquid material from a discharge device, the discharge device comprising a nozzle for discharging the liquid material in droplets, and

the droplet discharge method comprising the steps of:

cleaning the nozzle by discharging the liquid material from the nozzle; and

disposing the liquid material on the substrate by discharging the liquid material from the nozzle,

wherein the liquid material used in the cleaning step is disposed on the substrate, and the quantity of the liquid material disposed on the substrate in the step of cleaning and the quantity of the liquid material disposed on the substrate in the step of disposing constitute the specified quantity.

2. (Original) A droplet discharge method according to claim 1, wherein the liquid material is warmed to room temperature or higher.

3. (Previously Presented) A manufacturing method for a liquid crystal device for a liquid crystal in a specified quantity on a first substrate by discharging the liquid crystal from a discharge device,

the discharge device comprising a nozzle for discharging the liquid crystal in droplets, and

the manufacturing method comprising the steps of:

cleaning the nozzle by discharging the liquid crystal from the nozzle; and

disposing the liquid crystal on the first substrate by discharging the liquid crystal from the nozzle,

wherein the liquid crystal used in the cleaning step is disposed on the first substrate, and the quantity of the liquid crystal disposed on the first substrate in the step of cleaning and the quantity of the liquid crystal disposed on the first substrate in the step of disposing constitute the specified quantity.

4. (Original) A manufacturing method for a liquid crystal device according to claim 3,

wherein a sealing material for adhering the first substrate to a second substrate is arranged on the first substrate, and

a specified quantity of liquid crystal is arranged on the first substrate, away from the sealing material.

5. (Original) A manufacturing method for a liquid crystal device according to claim 4, wherein after the first substrate and the second substrate are adhered to each other via said sealing material, the liquid crystal is spread over a whole space between the first substrate and the second substrate.

6.-7. (Canceled)

8. (Previously Presented) A droplet discharge apparatus which disposes a liquid material in a specified quantity on a substrate, comprising:

a nozzle for discharging the liquid material in droplets;

a liquid material supply system which supplies the liquid material to the nozzle;

and

a measuring device which measures a quantity of the liquid material disposed on the substrate;

wherein a quantity of the liquid material disposed on the substrate is measured by the measuring device, and the discharge of the liquid material from the nozzle is stopped when the quantity of the liquid material disposed on the substrate reaches the specified quantity.

9. (Original) A droplet discharge apparatus according to claim 8, further comprising;

a temperature control device which warms the liquid material to room temperature or higher.

10. (Original) A liquid crystal device, comprising at least one component of a component group consisting of a liquid crystal layer, an oriented film, and a protection film for a color filter,

wherein the droplet discharge apparatus according to claim 8 is used to form at least one component of the component group.

11. (Original) An electronic apparatus comprising the liquid crystal device according to claim 10.

12. (New) A droplet discharge method according to claim 1, wherein the nozzle is movable between a first position and a second position with respect to the substrate and the cleaning step is performed in the first position and the disposing the liquid material step is performed in the second position.

13. (New) A droplet discharge method according to claim 12, wherein the disposing the liquid material step further comprises measuring a weight of the liquid material.

14. (New) A droplet discharge method according to claim 1, wherein the cleaning step further comprises flushing by vigorously pushing the liquid material through the nozzle.

15. (New) A droplet discharge method according to claim 1, wherein the cleaning step eliminates a clogging of the nozzle.

16. (New) A droplet discharge method according to claim 1, wherein the disposing the liquid material step further comprises controlling the quantity of the liquid material being disposed on the substrate by controlling a weight of the liquid material that has been disposed on the substrate.

17. (New) A droplet discharge method according to claim 16, wherein the weight of the liquid material that has been disposed on the substrate is controlled by discharging droplets of a smaller size than a normal discharge size of the droplets.

18. (New) A droplet discharge apparatus according to claim 8, further comprising a controller,

wherein the measuring device measures a weight of the liquid material that has been disposed on the substrate, and

the controller is adapted to control the quantity of the liquid material being disposed on the substrate by controlling the weight of liquid material that has been disposed on the substrate.